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PMT orders maskless lithography system from EV Group - January 25, 2024

PMT has ordered a LITHOSCALE® maskless exposure system from EVG. The LITHOSCALE system will be installed at PMT's headquarters in Asan-si, Chungcheongnam-Do, South Korea, where it will be used in the production of next-generation MEMS-based probe cards for wafer-level testing of advanced NAND, DRAM and HBM devices. "We can achieve significant cost savings, faster process development, and improved process performance, by switching from traditional lithography to EV Group's LITHOSCALE maskless exposure product. We look forward to future collaborations with EVG leveraging LITHOSCALE and other process solutions for advanced probe card manufacturing." stated Dr. Yong-Ho Cho, CEO of PMT. Incorporating EVG's MLETM (maskless exposure) technology, LITHOSCALE addresses lithography needs for markets and applications that require a high degree of flexibility or product variation.

